Docket No.: 60188-625 PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

:

Hisashi OGAWA, et al.

:

Serial No.: Divisional of

Application Serial No. 10/196,229

: Group Art Unit: Not yet assigned

Filed: September 08, 2003

Examiner: Not yet assigned

For:

SEMICONDUCTOR MEMORY AND METHOD FOR FABRICATING THE SAME

PRELIMINARY AMENDMENT

Mail Stop Patent Application Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Prior to examination of the above-referenced application, please amend the application as follows:

Please amend the specification as reflected in "Amendment to the Specification" on page 2 of this preliminary amendment.